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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Here the application of:

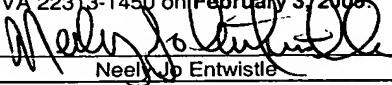
John M. de Larios

Application No. 10/608,871

Filed: June 27, 2003

For: **METHOD AND APPARATUS FOR
REMOVING A TARGET LAYER FROM A
SUBSTRATE USING REACTIVE GASES**

)
Group Art Unit: 1746
)
Examiner: Unassigned
)
Atty. Docket No. LAM2P422
)
Date: February 3, 2005
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CERTIFICATE OF MAILING	
I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on February 3, 2005.	
Signed:	 Michael K. Hsu
Neely & Entwistle	

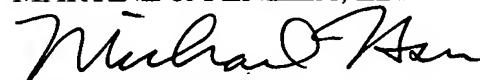
REQUEST FOR STATUS

Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

Applicant hereby requests status of the above-referenced patent application. This application was filed on June 27, 2003, and no response has been received as of this date.

Respectfully submitted,
MARTINE & PENILLA, LLP


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